



Docket No.: 6317P013 Jfw

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MEIR ALONI, ET AL.

Application No.: 10/661,719

Filed: September 11, 2003

For: **Raster Frame Beam System For Electron Beam Lithography**

Art Group:

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In accordance with the duty of disclosure, enclosed is a copy of IDS Citation Form PTO/SB/08 or PTO-1449, together with copies of the documents cited on that form, except for copies not required to be submitted (e.g., copies of U.S. patents and U.S. published patent applications need not be enclosed for applications filed after June 30, 2003). This IDS and IDS Citation Form are being submitted. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

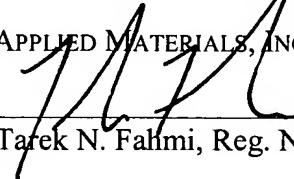
The references were cited in a Search Report dated July 8, 2004 (copy enclosed herewith) in a counterpart PCT application.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Date: September 08, 2004

Respectfully submitted,

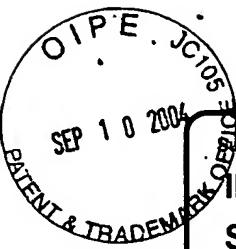
APPLIED MATERIALS, INC.


Tarek N. Fahimi, Reg. No. 41,402

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I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Box: IDS, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Carla Nascimento 09-08-04
Date



Substitute for form 1449APTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet	1	of	2	Examiner Name	Not Yet Assigned
				Attorney Docket Number	6317P013

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

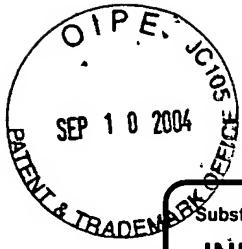
Examiner Signature		Date Considered	
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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SEP 10 2004

Substitute for form 1449A/PTO				<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/661,719
				Filing Date	September 11, 2003
				First Named Inventor	Meir Aloni
				Art Unit	
				Examiner Name	Not Yet Assigned
Sheet	2	of	2	Attorney Docket Number	6317P013

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
		HIROSHI YASUDA, SOICHIRO ARAI, JUN-ICHI KAI, YOSHIHISA OOA, TOMOHIKO ABE, SHIGERU MARUYAMA, AND TAKASHI KIUCHI, "Multielectron beam blanking aperture array system SYNAPSE-2000", 11/1/1996, pages 3813-3820, American Vacum Society, New York, U.S.			
		"International Search Report", International Searching Authority, PCT/ US 03/34785, (7/08/2004)			

Examiner Signature	Date Considered
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